

Docket No.: SUT-9004/DIV (PATENT)

### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Letters Patent of: Hideo Sugai et al.

Patent No.: 6,744,211

Issued: June 1, 2004

For: PLASMA DENSITY INFORMATION MEASURING METHOD PROBE USED FOR MEASURING PLASMA DENSITY INFORMATION, A PLASMA DENSITY INFORMATION MEASURING APPARATUS

Certificate NOV 2 2 2004 of Correction

# REQUEST FOR CERTIFICATE OF CORRECTION PURSUANT TO 37 CFR 1.323

MS Post Issue Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Upon reviewing the above-identified patent, Patentee noted a typographical error which should be corrected.

In the Second Assignee:

At page 1, please correct the second assignee from Nagoya University to President of Nagoya University.

The error was found in the application as filed by applicant. Please charge our Deposit Account No. 18-0013 in the amount of \$100.00 covering the fee set forth in 37 CFR 1.20(a).

The error now sought to be corrected is an inadvertent typographical error the correction of which does not involve new matter or require reexamination.

11/18/2004 NNGUYEN2 00000152 180013 6744211

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Patent No.: 6,744,211 Docket No.: SUT-9004/DIV

Transmitted herewith is a proposed Certificate of Correction effecting such amendment. Patentee respectfully solicits the granting of the requested Certificate of Correction.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 18-0013, under Order No. SUT-9004/DIV. A duplicate copy of this paper is enclosed.

Dated: November 17, 2004

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Respectfully submitted

By David T. Nikaido

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Lee Cheng

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PTO/SB/17 (10-04v2) Approved for use through 7/31/2006. OMB 0651-0032

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	ı				Hideo Sugai			
Effective 10/01/2004. Patent fees are subject to annual revision				xaminer Name J. T. Vu				
Applicant claims small entity status. See 37 CFR 1.27	ı	Art Ur	iit	•		2821		
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SUBMITTED BY						(Complete	(if applicable))	
Name (Print/Type) David T. Nikaido/Lee Cheng		istration No. 22,663/40,949 Telephone (202) 955-3750						
Signature			•			Date	November 17, 2	2004

PTO/SB/44 (04-04)
Approved for use through 04/30/2007. OMB 0651-0033
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(Also Form PTO-1050)

## UNITED STATES PATENT AND TRADEMARK OFFICE CERTIFICATE OF CORRECTION

PATENT NO.

6,744,211

**DATED** 

June 1, 2004

INVENTOR(S) :

Hideo Sugai et al.

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

## Second Assignee:

From "Nagoya University" to -- President of Nagoya University--.

MAILING ADDRESS OF SENDER: David T. Nikaido RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036

PATENT NO. 6,744,211

No. of additional copies 1



## (12) United States Patent

Sugai et al.

(10) Patent No.:

US 6,744,211 B2

(45) Date of Patent:

Jun. 1, 2004

(54)	PLASMA DENSITY INFORMATION
•	MEASURING METHOD, PROBE USED FOR
	MEASURING PLASMA DENSITY
	INFORMATION, AND PLASMA DENSITY
	INFORMATION MEASURING APPARATUS

(75) Inventors: Hideo Sugai, Kasugai (JP); Seiichi Takasuga, Takarazuka (JP); Naoki

U.S.C. 154(b) by 420 days.

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(73)	Assignees: Nissin Inc., Hyogo (JP) Nagoya [University, Aiii (JP)]	η
	University, Aiti (JP)	

Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35

Appl. No.: 09/972,944 (21)

(22)Filed: Oct. 10, 2001

(65)**Prior Publication Data** 

US 2002/0047543 A1 Apr. 25, 2002

#### Related U.S. Application Data

Division of application No. 09/357,773, filed on Jul. 21,

#### (30)Foreign Application Priority Data

(51) <b>I</b>	nt. Cl. <sup>7</sup>	 	F	H01J 7/2	4
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156/345 (58)315/111.51, 111.71, 111.81, 111.91; 118/723 I, 723 IR, 723 AN; 156/345; 324/576

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#### U.S. PATENT DOCUMENTS

5,111,111 A 5/1992 Stevens et al. ....... 315/111.41 Primary Examiner—Tuyet Vo Assistant Examiner-Jimmy T. Vu (74) Attorney, Agent, or Firm-Rader, Fishman & Grauer PLLC

#### (57)**ABSTRACT**

A plasma density information measuring method capable of easily measuring the plasma density information over the long term, a probe for measuring the plasma density information, and a plasma density information measuring apparatus are disclosed. A measuring probe is set such that a tip end of a glass tube of the measuring probe is brought into contact with plasma PM to be measured. Highfrequency power sent through a coaxial cable is supplied to the plasma PM from a loop antenna through a wall of the tube, and reflection power of the high-frequency power is received by the loop antenna to obtain a counter frequency variation of reflection coefficient of the high-frequency power. In the obtained reflection coefficient, a portion thereof in which the reflection coefficient is largely reduced is a peak at which strong absorption of high-frequency power is caused due to the plasma density. The plasma density can be obtained from the plasma absorption frequency.

#### 12 Claims, 14 Drawing Sheets

